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Docket: 0756-1984

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Shunpei Yamazaki) **RECEIVED**
Serial No. 09/334,646) Art Unit: 2811 **OCT 19 2000**
Filed: June 17, 1999) Examiner: S. HU **TECHNOLOGY CENTER 2800**
For: SEMICONDUCTOR DEVICE)
AND FABRICATION METHOD)
THEREFOR)

INFORMATION DISCLOSURE STATEMENT CERTIFICATE OF MAILING

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 10-4-00

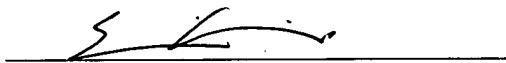
In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application.

I hereby certify that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Statement, specifically, in an Office Action from the Korean Patent Office dated July 31, 2000. Inasmuch these references are being submitted within three months of the date of the aforementioned Office Action, it is believed that no fee is required.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The Commissioner is hereby authorized to charge fees under 37 CFR 1.16 and 1.17 (except the Issue Fee) which may be required now or hereafter, or credit any overpayment, to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.

Respectfully submitted,


Eric J. Robinson
Registration No. 38,285

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110

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